

## PAPER

## A CMOS Rail-to-Rail Current Conveyor

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**SUMMARY** This paper presents a second-generation CMOS current conveyor (CCII) consisting of a rail-to-rail complementary n- and p-channel differential input stage for the voltage input, a class AB push-pull stage for the current input, and current mirrors for the current outputs. The CCII was implemented using a double-poly triple-metal 0.6  $\mu\text{m}$  n-well CMOS process, to confirm its operation experimentally. A prototype chip achieves a rail-to-rail swing  $\pm 2.3\text{V}$  under  $\pm 2.5\text{V}$  power supplies and shows the exact voltage and current following performances up to 100 MHz. Because of its high performances, the CCII proposed herein is quite useful for a building block of current-mode circuits.

**key words:** current conveyor, CMOS integrated circuit, rail-to-rail, class AB, wideband

## 1. Introduction

A recent trend toward a large electronic system on a chip drives CMOS process to the submicrometer feature size. One of the biggest problems associated with the high density packing by the reduced feature size is the power dissipation, and electronic circuits are obliged to operate under the low supply voltage. To meet such requirements as the wide dynamic range and the wide bandwidth operations under the low supply voltage, current-mode analog signal processing is receiving much attention as a voltage-mode alternative. An op-amp equivalent in current-mode circuits is the second-generation current conveyor (CCII), and its CMOS realization is highly requested to facilitate the analog circuit design in a mixed analog and digital CMOS ASIC [1], [2].

The CCII is a three-terminal device whose terminal relations can be expressed by the following matrix representation:

$$\begin{bmatrix} i_y \\ v_x \\ i_z \end{bmatrix} = \begin{bmatrix} 0 & 0 & 0 \\ 1 & 0 & 0 \\ 0 & \pm 1 & 0 \end{bmatrix} \begin{bmatrix} v_y \\ i_x \\ v_z \end{bmatrix}, \quad (1)$$

where  $v_y$ ,  $i_x$ , and  $v_z$  are the excitations applied to the voltage input terminal  $Y$ , the current input terminal  $X$ , and the current output terminal  $Z$ , respectively, and  $i_y$ ,

$v_x$ , and  $i_z$  are the responses to these excitations. The element  $\pm 1$  in the matrix assumes  $+1$  if the direction of  $i_z$  is the same as that of  $i_x$  and  $-1$  otherwise.

The ideal characteristics given by (1) indicate that the CCII is characterized in terms of the terminal impedances and the voltage- and current-following performances [3], [4]. These performances can be achieved by a source follower and a current mirror. The CCII can thus be realized by combining these simple circuits such that the output of the source follower be the input of the current mirror. Such an architecture exhibits an excellent current-following action over the wide bandwidth, but suffers from the poor voltage-following performance due to the high output impedance of the follower [5]–[9]. To reduce the output impedance, the constant potential and current feedback techniques have been proposed [10], [11], but the output swing limited by the source follower remains unsolved.

Much better voltage-following performance can be realized by the op-amp with unity-gain configuration. The rail-to-rail input and output capabilities can also be provided with the op-amp under class AB operation [12]–[17]. Based on this idea, a CMOS rail-to-rail CCII is developed. Its circuit configuration, simulated performances, and a prototype chip fabricated using 0.6  $\mu\text{m}$  CMOS process will be described in the followings.

## 2. Circuit Description

The circuit configuration of the CMOS rail-to-rail CCII is shown in Fig. 1, where  $Y$  is the voltage input terminal,  $X$  is the voltage/output current input terminal, and  $\pm Z$  are the current output terminals. It comprises five blocks; the rail-to-rail input stage consisting of the

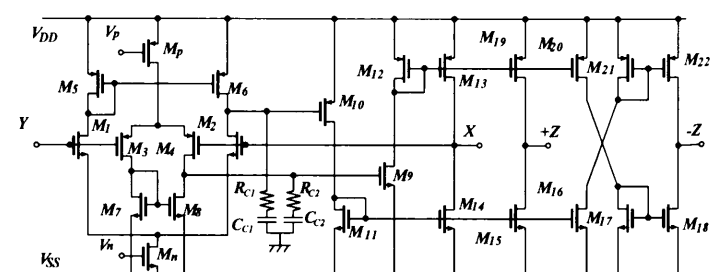


Fig. 1 The circuit diagram of the proposed rail-to-rail CCII.

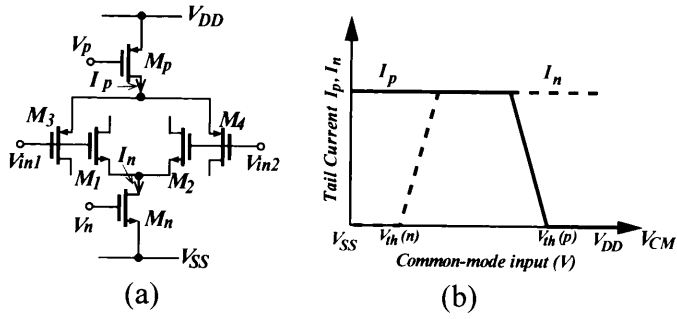
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**Fig. 2** (a) An input stage model of the rail-to-rail input stage. (b) The tail currents in the rail-to-rail input stage.

complementary n- and p-channel differential pairs ( $M_1$ – $M_8$ ) for the voltage input  $v_y$ , the phase compensation and the level shift stage ( $R_{C1}$ ,  $R_{C2}$ ,  $C_{C1}$ ,  $C_{C2}$ ,  $M_9$ – $M_{12}$ ), the rail-to-rail class AB push-pull stage ( $M_{13}$ ,  $M_{14}$ ) for the voltage output/current input  $i_x$ , the current mirrors ( $M_{15}$ – $M_{22}$ ) for the current outputs  $i_{\pm z}$ , and the bias stage. The differential input, level shift, and class AB push-pull stages form the operational transconductance amplifier (OTA).

### 2.1 Complementary Input Stage

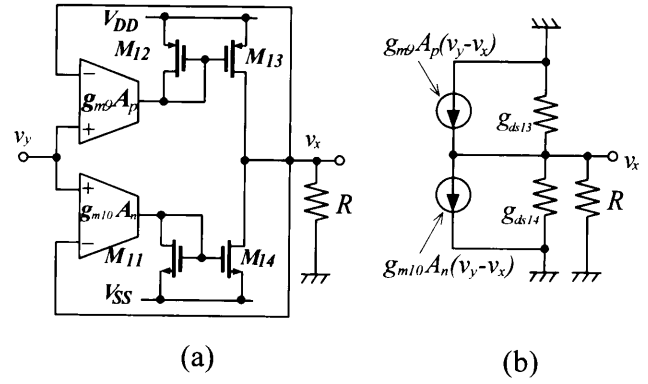
The schematic of the complementary input stage is shown in Fig. 2(a), where n- and p-channel differential pairs are connected in parallel. The operation can be divided into three regions shown in Fig. 2(b): The positive rail region where only nMOS pair is active, the mid-rail region where both nMOS and pMOS pairs are active, and the negative rail region where only pMOS pair is active. The transconductance  $g_m$  of the input stage therefore depends on the input voltage. The dependence may cause the harmonic distortion, but the common-mode feedback to make  $g_m$  independent of the input voltage is not incorporated. This is because the OTA forms the voltage follower by the fully feedback configuration and this configuration reduces the harmonic distortion by a factor of the open-loop gain of the OTA.

### 2.2 Voltage Following Operation

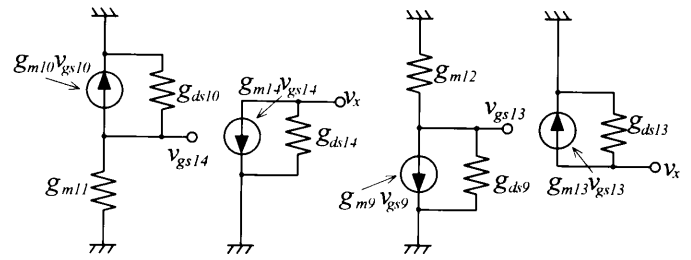
Regarding the voltage and current input stages as the input and output stages of the OTA, respectively, one can model the input stage as shown in Fig. 3(a). Figure 3(b) shows the small-signal equivalent circuit. Referring to this model, one obtains the voltage transfer gain  $A_v$  from the node Y to the node X:

$$A_v = \frac{v_x}{v_y} = \frac{(g_{m9}A_p + g_{m10}A_n)R}{1 + (g_{m9}A_p + g_{m10}A_n)R}, \quad (2)$$

where  $A_n$  and  $A_p$  are the gains of the n- and p-channel differential stages,  $g_m$  is the transconductance of MOS transistor and  $R$  is a load resistor at the node X.  $A_v$  is very close to 1 since  $(g_{m9}A_p + g_{m10}A_n)R \gg 1$  holds usually. Therefore,  $v_x$  exactly follows  $v_y$ .



**Fig. 3** The input stage model of the CCII (a) and its small-signal equivalent circuit (b).



**Fig. 4** The small-signal equivalent circuits at the drains of  $M_{13}$  and  $M_{14}$ .

### 2.3 Input/Output Impedance at Node X

Figure 4 shows the small-signal equivalent circuits at the node X. Referring to Fig. 4, the impedance  $r_{xn}$  presented by  $M_{14}$  is given by

$$r_{xn} = \frac{1}{g_{ds14} + \frac{g_{m14}g_{m10}A_n}{g_{m11} + g_{ds10}}}, \quad (3)$$

where  $g_{ds}$  is the drain-source conductance of MOS transistor.

Similarly, the impedance  $r_{xp}$  presented by  $M_{13}$  is given by

$$r_{xp} = \frac{1}{g_{ds13} + \frac{g_{m13}g_{m9}A_p}{g_{m12} + g_{ds9}}}. \quad (4)$$

The impedance  $r_x$  at the node X is the parallel connection of  $r_{xn}$  and  $r_{xp}$ , and thus

$$\begin{aligned} r_x &= \frac{1}{g_{ds14} + \frac{g_{m14}g_{m10}A_n}{g_{m11} + g_{ds10}}} // \frac{1}{g_{ds13} + \frac{g_{m13}g_{m9}A_p}{g_{m12} + g_{ds9}}} \\ &= \frac{1}{\frac{g_{m13}g_{m9}A_p}{g_{m12}} + \frac{g_{m14}g_{m10}A_n}{g_{m11}}} = \frac{1}{g_{m9}A_p + g_{m10}A_n}. \end{aligned} \quad (5)$$

In deriving the last expression,  $g_{ds} \ll g_m$ ,  $g_{m12} = g_{m13}$ , and  $g_{m11} = g_{m14}$  are assumed.

Equation (5) indicates that the impedance at the node X of a basic CCII is reduced by the open loop gain of the differential stage. With the simple configuration shown in Fig. 1, the gain higher than 40 dB can be realized. It follows therefore that the node X in Fig. 1 is virtually grounded when the node Y is grounded.

#### 2.4 Rail-to-Rail Class AB Output Stage

Referring again to Figs. 1 and 4, one obtains the following expressions for the current flowing through  $M_{13}$  and  $M_{14}$ :

$$i_{d13} = J + g_{ds13}v_{d13} - \frac{g_{m9}g_{m13}A_p(v_y - v_x)}{g_{m12} + g_{ds9}}, \quad (6)$$

$$i_{d14} = J + g_{ds14}v_{d14} + \frac{g_{m10}g_{m14}A_n(v_y - v_x)}{g_{m11} + g_{ds10}}, \quad (7)$$

where

$$v_{d13} = V_{DD} - v_x, \quad (8)$$

$$v_{d14} = v_x - V_{SS} \quad (9)$$

In (6) and (7), the same quiescent current  $J$  is assumed flowing through  $M_{13}$  and  $M_{14}$ . Because of the exact voltage-following action  $v_y = v_x$  and  $g_{ds} \ll 1$ , the ac components in (6) and (7) are much smaller than the quiescent current. Then

$$\begin{aligned} v_{gs14} + v_{gs13} &= \sqrt{\frac{i_{d13}}{K_{13}}} + V_{th13} + \sqrt{\frac{i_{d14}}{K_{14}}} + V_{th14} \\ &\approx \sqrt{\frac{J}{K}} \left( 2 + \frac{g_{ds}(V_{DD} - V_{SS})}{2J} \right) + V_{th13} + V_{th14} \\ &= \text{const.} \end{aligned} \quad (10)$$

where  $K_{13}$  and  $K_{14}$  are the transconductance parameters of  $M_{13}$  and  $M_{14}$ , respectively, and  $K_{13} = K_{14} = K$  and  $g_{ds13} = g_{ds14}$  are assumed to derive the last expression. Equation (10) indicates that  $M_{13}$  and  $M_{14}$  operate under the push-pull mode.

The current  $i_x$  applied to the node X is shared between  $M_{13}$  and  $M_{14}$ . Taking the push-pull condition (10) into account, one can derive the following expressions for  $i_{d13}$  and  $i_{d14}$ :

$$i_{d14} = J - i_x/2 + i_x^2/16J, \quad (11)$$

$$i_{d13} = J + i_x/2 + i_x^2/16J. \quad (12)$$

Equations (11) and (12) indicate that the push-pull operation continues until  $i_x$  reaches  $\pm 4J$  where the single-ended operation starts, as shown in Fig. 5. The maximum current is limited by the voltage headroom in the push-pull stage.

#### 2.5 Current Following Operation

Figure 6 shows the lower half section of the current

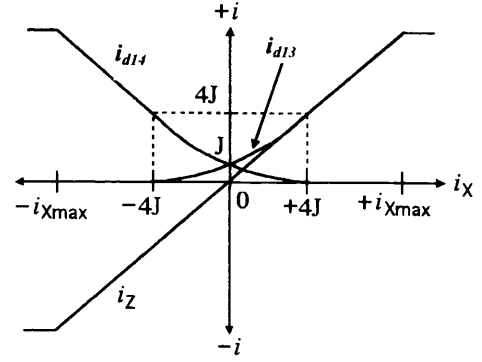


Fig. 5 The current transfer characteristics.

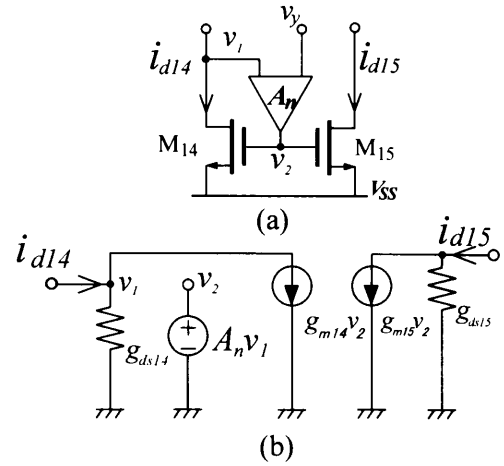


Fig. 6 The active current mirror (a) and its small-signal equivalent circuit (b).

input and output stages. The differential stage  $A_n$ ,  $M_{14}$ , and  $M_{15}$  form the active current mirror [18]–[20]. Referring to the equivalent circuit shown in Fig. 6(b), one can derive the following expression for the current transfer:

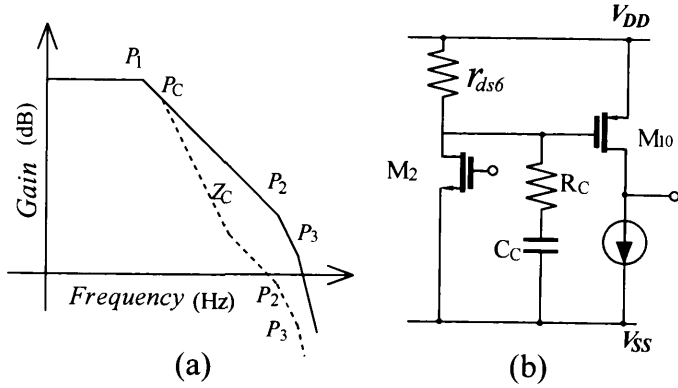
$$\frac{i_{d15}}{i_{d14}} = \frac{1}{\frac{1}{g_{ds14}} + \frac{1}{A_n \times g_{m15}}}. \quad (13)$$

where  $g_{m14} = g_{m15}$  is assumed. Equation (13) indicates that the active current mirror achieves the exact mirror operation by reducing the input impedance effectively by the differential stage gain. The similar relation also holds true of the upper half section of the current input and output stages. Thus, under the quite reasonable assumption  $A_n g_{m15} \gg g_{ds14}$ , we have

$$i_z = i_{d19} - i_{d16} = i_{d13} - i_{d14} = i_x. \quad (14)$$

#### 2.6 Phase Compensation

The OTA in Fig. 1 has three poles; the dominant pole  $P_1$  presented by  $M_8$  ( $M_6$ ), the second pole  $P_2$  by  $M_9$  ( $M_{10}$ ), and the third pole  $P_3$  by the output node X. The Bode diagram when the OTA is loaded by  $1 \text{ k}\Omega$  is



**Fig. 7** Bode diagrams of the OTA (a) and the phase compensation network (b).

sketched in Fig. 7(a). The two high-frequency poles  $P_2$  and  $P_3$  are located closely in this configuration. Such a pole location invalidates the pole-splitting and phase-lead techniques for the phase compensation, and the phase-lag method is applied though it degrades the high-frequency performance. The compensated Bode diagram is shown by the dotted line in Fig. 7(a) and the compensation network is shown in Fig. 7(b). The pole  $f_{PC}$  and zero  $f_{ZC}$  frequencies introduced by the network are given by

$$f_{PC} = \frac{1}{2\pi C_c (r_{ds6} + R_C)}, \quad (15)$$

$$f_{ZC} = \frac{1}{2\pi C_c R_C}. \quad (16)$$

Locating  $f_{PC}$  and  $f_{ZC}$  between  $P_1$  and  $P_2$  stabilizes the OTA, as shown in Fig. 7(a), because the open-loop gain crosses 0 dB with the slope  $-20$  dB/Decade.

### 3. Performances

#### 3.1 Simulations

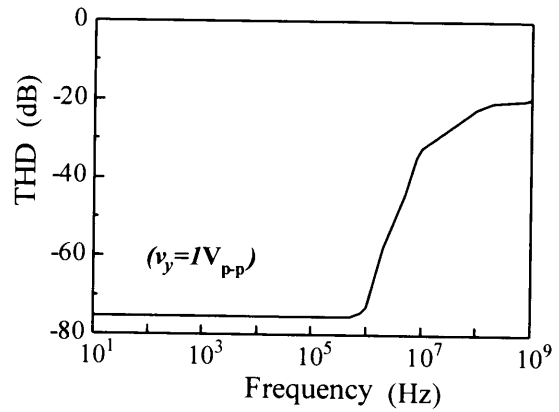
Performances of the CCII shown in Fig. 1 are simulated using HSPICE. Transistor dimensions and the compensation elements are listed in Table 1. The parameters used for the simulations assume  $0.6 \mu\text{m}$  CMOS process. Supply voltages are  $V_{DD} = -V_{SS} = 2.5 \text{ V}$  and  $I$  is set to  $50 \mu\text{A}$ . Simulated performances are shown by solid and dotted lines in the following figures.

Figure 8 shows the total harmonic distortion (THD) in the voltage follower when  $1 \text{ V}_{p-p}$  sinusoidal signal is applied to the node Y and the node X is terminated by  $R_X = 1 \text{ k}\Omega$ . THD is lower than  $-75 \text{ dB}$  in the low-frequency region, but increases with frequency in the high-frequency region above  $1 \text{ MHz}$ . This is attributed due to the gain reduction in the differential stage which invalidates the push-pull condition (10).

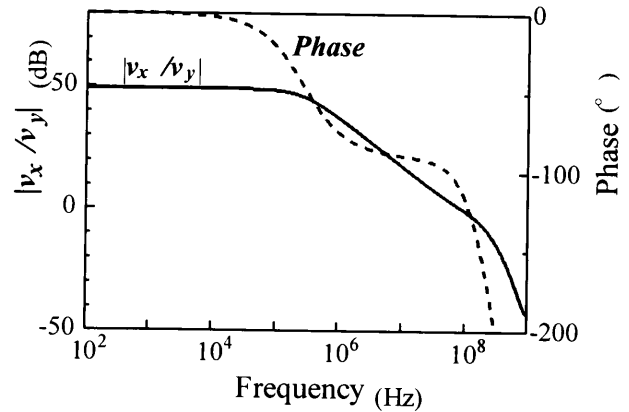
The Bode diagram of the OTA when the output node X is terminated by  $1 \text{ k}\Omega$  is shown in Fig. 9. The dc gain is  $49 \text{ dB}$ . The unity gain frequency is  $100 \text{ MHz}$  and the phase margin is  $60^\circ$ .

**Table 1** Transistor dimensions and the compensation elements.

Transistor	W ( $\mu\text{m}$ )	L ( $\mu\text{m}$ )
$M_1, M_2, M_7, M_8$	24	1.2
$M_3 - M_6$	60	1.2
$M_9, M_{11}, M_{14} - M_{18}$	42	1.2
$M_{10}, M_{12}, M_{13}, M_{19} - M_{22}$	126	1.2
Element values	( $\text{k}\Omega$ )	( $\text{pF}$ )
$R_{C1}, R_{C2}$	2	-
$C_{C1}, C_{C2}$	-	1



**Fig. 8** THD of the CCII.



**Fig. 9** The Bode diagram of the OTA.

Figure 10 shows the input characteristics at the node X. The positive sign in the current indicates the current flowing into the node and the minus sign the current flowing out of the node. The impedance  $r_x$  is  $6.67 \Omega$  in the push-pull region and decreases slightly in the single-ended region.

Figure 11 shows the voltage transfer characteristics from the node Y to the node X when the node Z is short-circuited to ground. The exact voltage-following performance and the rail-to-rail input and output capabilities are demonstrated. The offset voltage at the node X when the node Y is grounded is less than  $1.7 \text{ mV}$ .

Figure 12 shows the current transfer characteristics from the node X to the node Z. The transfer gains

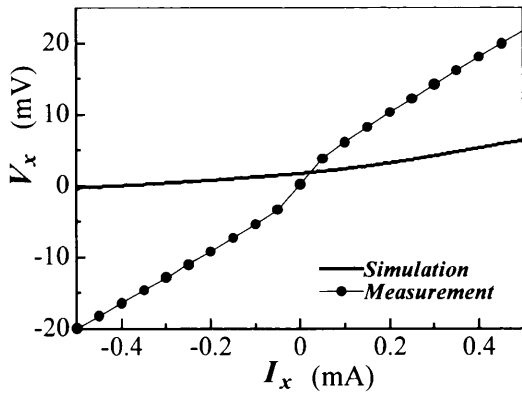


Fig. 10 The  $V_x$  versus  $I_x$  characteristics.

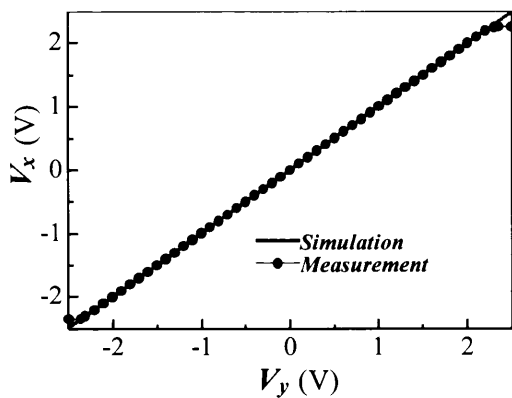


Fig. 11 The voltage transfer characteristics of the CCII.

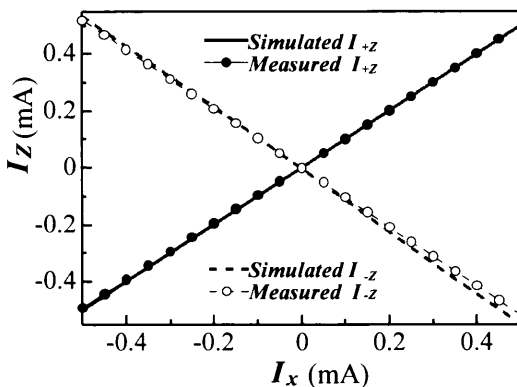


Fig. 12 The current transfer characteristics.

$I_{+z}/I_x$  and  $I_{-z}/I_x$  are 1.00 and  $-1.08$ , respectively, and the offset currents in  $I_{+z}$  and  $I_{-z}$  are 31.1 nA and 2.96 nA, respectively.

The frequency characteristics of the voltage gain when the node X is terminated by  $R_X = 1 \text{ k}\Omega$  are shown in Fig. 13. The  $-3 \text{ dB}$  bandwidth extends beyond 200 MHz.

Figure 14 shows the frequency characteristics of the current transfer gain. The bandwidth extends again beyond 150 MHz and no degradation due to the differential stage is observed.

Figure 15 shows the frequency dependence of the input impedance at the node X when the nodes Y and Z are grounded. Similarly to THD, the input impedance

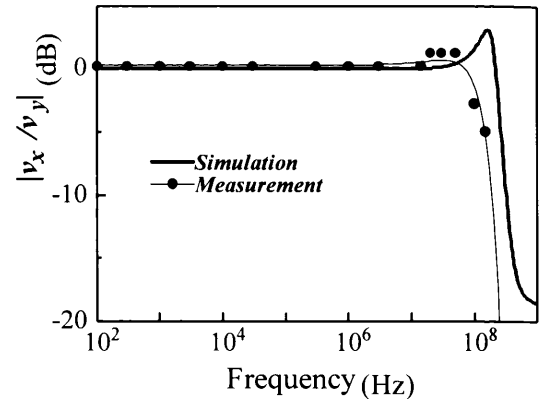


Fig. 13 The frequency characteristics of the voltage transfer gain.

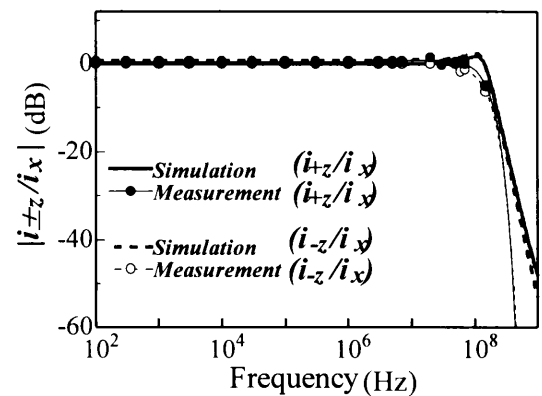


Fig. 14 The frequency characteristics of the current transfer gains.

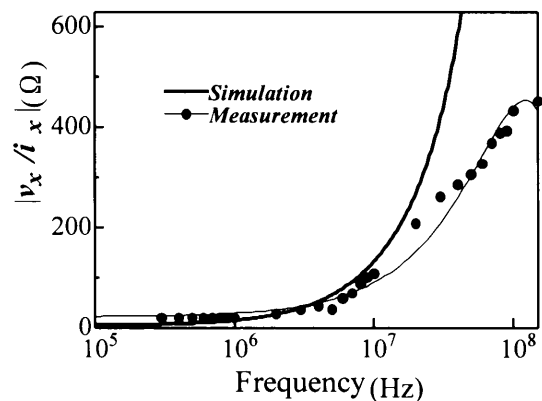


Fig. 15 The frequency dependence of the input impedance.

increases with frequency in the frequency region above 1 MHz. This is also due to the gain reduction in the differential stage.

### 3.2 Measured Performances

The proposed CCII was implemented using a double-poly, triple-metal  $0.6 \mu\text{m}$  n-well CMOS process. The microphotograph of the prototype chip is shown in Fig. 16. The chip measures  $250 \mu\text{m} \times 150 \mu\text{m}$ . All the measurements are done under  $\pm 2.5 \text{ V}$  supplies. The static current is  $300 \mu\text{A}$ . Measured performances are in-

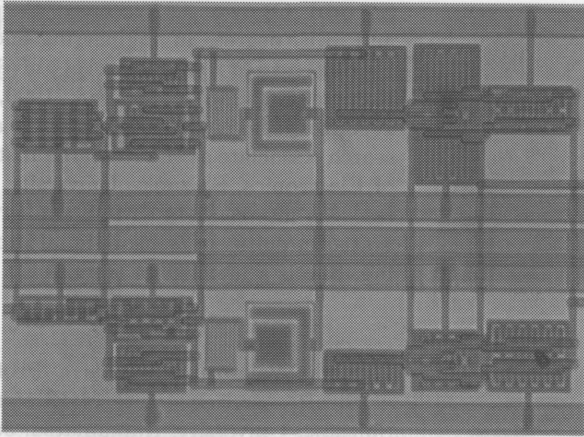


Fig. 16 A microphotograph of the prototype chip.

indicated by dots in the relevant figures.

The  $I_x$  versus  $V_x$  characteristics are plotted in Fig. 10. The measured input impedance  $r_x$  is  $41.7\ \Omega$  in the push-pull region. The simulated value is  $6.67\ \Omega$ . The large difference is attributed to the wire resistance between the node X and the ponding pad. The voltage transfer characteristics are plotted in Fig. 11, which demonstrates the exact voltage-following performance and the rail-to-rail input and output capabilities. The offset voltage at the node X when the node Y is grounded is less than  $30\ \mu\text{V}$ .

The current transfer characteristics are plotted in Fig. 12. The exact current-following performances in good agreement with the simulations can be seen over the wide current range. The transfer gains  $I_{+z}/I_x$  and  $I_{-z}/I_x$  are 1.00 and  $-1.03$ , respectively. The offset currents in  $I_{+z}$  and  $I_{-z}$  when the node Y is grounded are  $85\ \text{nA}$  and  $4\ \text{nA}$ , respectively.

The frequency characteristics of the voltage gain when the node X is terminated by  $R_X = 1\ \text{k}\Omega$  are plotted in Fig. 13. The  $-3\ \text{dB}$  bandwidth of the voltage gain  $v_x/v_y$  extends beyond  $100\ \text{MHz}$ . The frequency characteristics of the current transfer gains are plotted in Fig. 14. The bandwidth extends again beyond  $100\ \text{MHz}$ .

The frequency dependence of the input impedance at the node X is plotted in Fig. 15. In the low frequency range, the measured input impedance is higher than the simulated one. This is due to the wire resistance from the node X to the ponding pad, as explained earlier. In the high frequency range, on the other hand, the measured impedance is lower than the simulated one. This is due to the parasitic capacitance of the ponding pad.

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#### 4. Conclusions

A rail-to-rail CCII developed for wideband signal processing under low power operation was described. Performances measured in the prototype chip fabricated using  $0.6\ \mu\text{m}$  CMOS process are summarized in Ta-

Table 2 Performances of a prototype chip compared with those of the CCII proposed in [21]. \*: Simulated performances.

	Prototype chip	CCII in [21]
<u>Input/output voltage range</u>	<u><math>4.6\text{V}(5\text{V}^*)</math></u>	<u><math>2.4\text{V}^*</math></u>
Supply voltage	5V	3V
Impedance $r_x$ @DC	$41.7\ \Omega(6.67\ \Omega^*)$	$34\ \Omega^*$
Offset voltage	$30\ \mu\text{V}(1.7\text{mV}^*)$	$0.5\text{mV}^*$
Offset current	$I_{+z} : 85\text{nA}(31.1\text{nA}^*)$ $I_{-z} : 4\text{nA}(2.96\text{nA}^*)$	$I_{+z} : 450\text{nA}^*$ -
$-3\ \text{dB}$ bandwidth in voltage transfer	$120\text{MHz}(250\text{MHz}^*)$	$18\text{MHz}^*$
$-3\ \text{dB}$ bandwidth in current transfer	$120\text{MHz}(170\text{MHz}^*)$	$25\text{MHz}^*$

ble 2, together with those of the CCII proposed earlier [21]. Comparison demonstrates that the prototype chip is quite useful for wideband current signal processing. The operation under the single supply voltage as low as  $1\ \text{V}$  has been confirmed experimentally. Such a low-voltage operation and the small device-count are also quite attractive to ASICs. The commercial chip is now under fabrication using a standard digital CMOS process.

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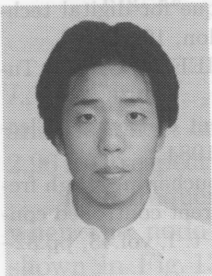
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